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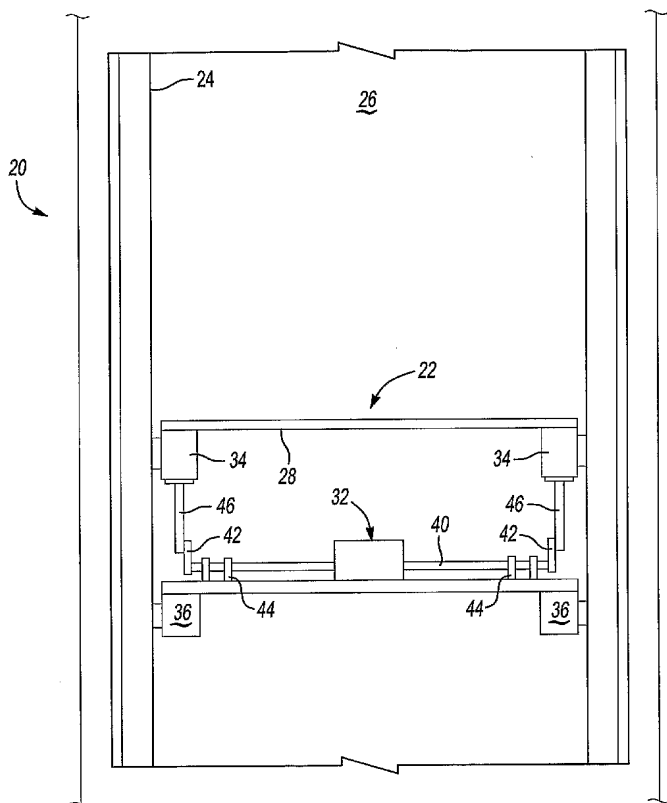
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(54) Title: A DEVICE FOR MOVING A PLATFORM ALONG ELEVATOR GUIDE RAILS



(57) Abstract: This invention generally relates to an assembly (22) for moving a platform (28) along guide rails (24) within an elevator shaft during installation of an elevator system. The assembly includes a first platform (28), a first holding device (34), a second platform (30) and a second holding device (36). The holding devices operate to allow movement in one direction and restrict movement in an opposite direction. A moving mechanism (32) cyclically urges the first and second platforms toward and away from each other. The holding devices allow only one of the platforms to move at a time responsive to the cyclical urging of the moving mechanism. This is sequentially repeated until the first platform is in a desired position.

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